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67124-014; R-05323

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Halwan
Serial No.: 10/736,260
Filed: 12/15/2003
Art Unit: 3744
Examiner: Jiang, Chen Wen
Title: **CONTROL LOGIC FOR MAINTAINING PROPER
SOLUTION CONCENTRATION IN AN ABSORPTION
CHILLER IN CO-GENERATION APPLICATIONS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Complying with Applicant's duty of disclosure, Applicant encloses a copy of a search report and written opinion received from a corresponding PCT patent application. Each item of information contained in the IDS was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the IDS.

The enclosed Form PTO 1449 lists the references cited in the International Search Report. A copy of the International Search Report and the foreign references are enclosed. Six of the nine references listed in the search report were previously presented in an information disclosure statement, filed with the United States Patent & Trademark Office on May 11, 2005.

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Applicant respectfully requests that the Examiner consider the remaining three references listed in the search report and make these cited references of record in this application.

Respectfully submitted,



Theodore W. Olds

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400 W. Maple Road, Ste. 350

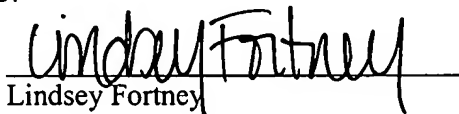
Birmingham, MI 48009

(248) 988-8360

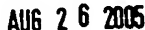
Dated: August 24, 2005

CERTIFICATE OF MAIL

I hereby certify that the enclosed Information Disclosure Statement and cited references are being deposited with the United States Postal Service as First Class Mail, postage prepaid, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 24 day of August, 2005.



Lindsey Fortney



Approved for use through 07/31/2006. OMB 0651-0031

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Substitute for form 449/PTO

(Use as many sheets as necessary)

Sheet	1	of	2
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Complete if Known

Application Number	10/736,260
Filing Date	12/15/2003
First Named Inventor	Halwan
Art Unit	3744
Examiner Name	Jiang, Chen Wen
Attorney Docket Number	67124-014; R-05323

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY			
		JP 06174325	06-24-1994	Kawasaki Heavy Ind Ltd		

Examiner Signature		Date Considered	
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>			Complete if Known	
			Application Number	10/736,260
			Filing Date	12/15/2003
			First Named Inventor	Halwan
			Group Art Unit	3744
			Examiner Name	Jiang, Chen Wen
Sheet 2	of 2	Attorney Docket Number	67124-014; R-05323	

[illegible]

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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